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Date

Susan F. Mahon

Docket No. 8733.20063

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Kwang Nam KIM, et al.

GAU: 2812

SERIAL NO: 09/430,037

EXAMINER: TBA

FILED: October 29, 1999

FOR: Method of Forming Silicon Oxide Layer and Method of Manufacturing Thin Film Transistor Thereby

REQUEST FOR PRIORITY

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

- ☐ Full benefit of the filing date of U.S. Application Serial Number [US App No], filed [US App Dt], is claimed pursuant to the provisions of 35 U.S.C. §120.
- ☐ Full benefit of the filing date of U.S. Provisional Application Serial Number, filed, is claimed pursuant to the provisions of 35 U.S.C. §119(e).
- ☒ Applicants claim any right to priority from any earlier filed applications to which they may be entitled pursuant to the provisions of 35 U.S.C. §119, as noted below.

In the matter of the above-identified application for patent, notice is hereby given that the applicants claim as priority:

COUNTRY

JAPAN

APPLICATION NUMBER

1998-309237

MONTH/DAY/YEAR

October 29, 1998

Certified copies of the corresponding Convention Application(s)

- ☒ are submitted herewith
- ☐ will be submitted prior to payment of the Final Fee
- ☐ were filed in prior application Serial No. filed
- ☐ were submitted to the International Bureau in PCT Application Number .
Receipt of the certified copies by the International Bureau in a timely manner under PCT Rule 17.1(a) has been acknowledged as evidenced by the attached PCT/IB/304.
- ☐ (A) Application Serial No.(s) were filed in prior application Serial No. filed ; and
(B) Application Serial No.(s)
 - ☐ are submitted herewith
 - ☐ will be submitted prior to payment of the Final Fee

Respectfully Submitted,

LONG ALDRIDGE & NORMAN LLP

Russell O. Craig Reg. No. 40,158 fo-
Kenneth D. Springer
Registration No. 39,843

Sixth Floor
701 Pennsylvania Avenue, N.W.
Washington, D.C. 20004
Tel. (202) 624-1200
Fax. (202) 624-1298

日 本 国 特 許 庁

PATENT OFFICE
JAPANESE GOVERNMENT

別紙添付の書類に記載されている事項は下記の出願書類に記載されている事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed with this Office.

出 願 年 月 日
Date of Application:

1 9 9 8 年 1 0 月 2 9 日

出 願 番 号
Application Number:

平成 1 0 年 特 許 願 第 3 0 9 2 3 7 号

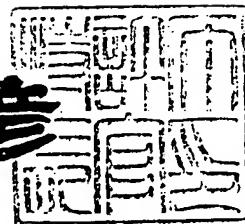
出 願 人
Applicant(s):

株式会社フロンテック

2 0 0 0 年 1 月 1 8 日

特 許 庁 長 官
Commissioner,
Patent Office

近 藤 隆 彦



出 証 番 号 出 証 特 平 1 1 - 3 0 8 3 7 0 3